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10/5/2009

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Arthur Sherman
App. No	: 10/683,727
Filed	: October 10, 2003
For	: SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	: Gambetta, Kelly M.
Art Unit	: 1792
Conf No.	: 1627

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action dated July 31, 2009 and is accompanied by a Declaration by Suvi Haukka under 37 C.F.R. § 1.132. Entry of the present amendments to cancel a claim and consideration of the subsequent remarks is respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.